Fabrication of Mesoporous Metal Chalcogenide Nanoflake Silica Thin Films and Spongy Mesoporous CdS and CdSe

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Abstract: Mesoporous silica metal oxide (ZnO and CdO) thin films have been used as metal ion precursors to produce the first examples of mesoporous silica metal sulfide (meso-SiO$_2$@ZnS, meso-SiO$_2$@CdS) or silica metal selenide (meso-SiO$_2$@ZnSe, meso-SiO$_2$@CdSe) thin films, in which the pore walls are made up of silica and metal sulfide or metal selenide nanoflakes, respectively. A gentle chemical etching with a dilute HF solution of the meso-SiO$_2$@CdS (or meso-SiO$_2$@CdSe) produces mesoporous cadmium sulfide (meso-CdS) (or cadmium selenide, meso-CdSe). Surface modified meso-CdS displays bright blue photoluminescence upon excitation with a UV light. The mesoporous silica metal oxides are formed as metal oxide nanoislands over the silica walls through a self-assembly process of a mixture of metal nitrate salt-two surfactants-silica source followed by calcination step. The reactions, between the H$_2$S (or H$_2$Se) gas and solid precursors, have been carried out at room temperature and monitored using spectroscopy and microscopy techniques. It has been found that these reactions are: 1) taking place through the diffusion of sulfur or selenium species from the top metal oxide layer to the silica metal oxide interface and 2) slow and can be stopped at any stage to obtain mesoporous silica metal oxide metal sulfide or silica metal oxide metal selenide intermediate thin films.

Keywords: mesoporous materials · metal selenides · metal sulfides · nanomaterials · thin films

Introduction

Chemistry at the nanoscale and/or mesoscale offers many new synthetic approaches for designing new materials with unique structures and functions. [1] Designing two or more materials in one, such as insulator–semiconductor, semiconductor–semiconductor, metal–insulator, and metal–semiconductor couples with an atomic precision is still a challenge in synthetic chemistry. In the last two decades, chemists have focused on solution based methods for the synthesis of multicomponent materials such as core-shell type structures, layer by layer assembly, and monolayer coatings. [2–6] There have also been many attempts to link nanoparticles to each other using organic linkers [7,8] or porous materials as hosts to grow second or third component in the channels. [9–21] However, all these methods require a second or third step and create in-homogeneities in size and shape distribution of the nanoparticles. The mesoporous materials in the form of thin films, monoliths, or powders with many different shapes have been known for the last 20 years; however uniform (size, shape, and composition) surface coating has always been a challenge. The mesoporous silica specifically MCM-41 and SBA-15 has been widely employed as a hard template to obtain transition-metal oxides, metals, and metal chalcogenide nanoparticles. [9–20] The major problem has always been the limited amount of metal ions that can be incorporated into the channels of mesoporous silica and their in-homogeneous distribution (as a result the oxides, metals, and/or chalcogenides in the channels are randomly sized and distributed). [9–13] There is definitely a demand for new synthetic methods to produce mesoporous metal oxides, metal sulfides, and metal selenides with or without silica (or another oxide, such as titania) for optoelectronic and solar energy applications. It is also important to note that the synthesis of pure and stable mesoporous metal sulfides and metal selenides has always been a challenge over the years. [18–26] There have been many attempts, using soft and hard templating methods, to overcome the stability problems. [18–26] Soft templating (lyotropic liquid crystalline templating, LLCT) produced either extremely small mesostructured metal sulfide powders [22–25] or even thin films [20] that are unstable to surfactant removal. [22–26] Hard or a combination of hard/soft templating methods have also been investigated by many groups, but these methods always produced nanoparticles or nanowires in the channels of the mesoporous host. [9–21] It is worth to mention that there are also a few studies on metal sulfide aerogels with a relatively high surface area, however with a much thicker walls. [27–50] Recently, we have discovered that some transition-metal salts can be kept in their liquid phase in the hydrophilic domains of LLC mesophase of a salt–surfactant system. [51] The same concept has already been used to

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Supporting information for this article is available on the WWW under http://dx.doi.org/10.1002/chem.201102643.
design the first homogenously metal oxide coated mesoporous silica thin films in which the metal oxide layer can be more than 53 mole percent (about 70% w/w) and as thin as 1.3 to 1.7 nm. In this self-assembly process, the salt species act as solvents, like water, in the media to organize the surfactant molecules into LLC mesophases and metastable salt–surfactant–silica mesostructured thin films. The silica walls can be fully or partially coated with crystalline ultra thin metal oxide layers that can be converted into metal sulfide (or metal selenide) coated silica. The silica walls can be etched out to form stable mesoporous metal sulfide (or metal selenide) thin films.

Herein, the synthetic pathway of mesoporous metal sulfide (or metal selenide) silica (MOMSS) and pure metal sulfide (and metal selenide) (MMS) has been investigated. It has been proven that the oxide over layers can be partially or fully reacted with H₂S or H₂Se at RT to convert them into metal sulfides or metal selenides. Both reactions, H₂S and H₂Se, can be controlled, as a result the metal oxide and metal sulfide (or metal selenide) thickness in the MOMSS films, using exposure time and monitored using FTIR, UV/Vis, and EDS spectroscopic techniques. Pure MMS thin films were also obtained by carefully etching the silica from the MMSS thin films. The film samples, at each stage, were characterized using TEM, SEM, EDS, UV/Vis, FTIR, Raman, and XRD techniques.

Results and Discussion

Mesoporous silica metal sulfide/selenide and cadmium sulfide/selenide thin films: The 400-600 nm thin films of the mesoporous silica zinc oxide and silica cadmium oxide have been prepared using the procedure established in our earlier work. The films were obtained by first spin coating a homogenized clear solution of [M(H₂O)₆]([NO₃]₃-H₂O-CTAB-HNO₃-C₁₂EO₁₀-TMOS (M is Zn II or Cd II and x is 6 for Zn and 4 for Cd salts) mixture and then, immediately, calcined starting from 55 and 65 °C to 450 °C, respectively. This process gives mesoporous silica metal oxide thin films (denoted as meso-SiO₂-MO-n, M is Zn or Cd and n is the M/Si mole ratio), where the metal oxide forms nanobilands with a thickness of around 1.6 nm over the silica walls (see ref. for details).

The meso-SiO₂-MO-n thin films were exposed to a H₂S or H₂Se atmosphere to obtain mesoporous silica metal sulfide and silica metal selenide thin films. The reactions were carried out under a 300 Torr H₂S atmosphere at RT to prepare meso-SiO₂@ZnS-n and meso-SiO₂@CdSe-n (where n is 0.29, 0.57, 0.86, and 1.14) and 300 Torr mixture of 5% H₂Se in pure N₂ to prepare meso-SiO₂@ZnSe-n and meso-SiO₂@CdSe-n samples. In a total of 16 samples, 4 samples from each set, were prepared with increasing metal ion content and were characterized using spectroscopy, microscopy, and diffraction techniques. Figure 1 shows a typical SEM image of meso-SiO₂@CdS-0.86 after H₂S reaction. Disordered/non-uniform sponge-like pores, ranging from 3 to 20 nm (meso- pores) and 50–100 nm (macro-pores) are visible in the images. The images of all other samples display similar surface morphology and texture. The complete conversion of the metal oxides to metal sulfides or to metal selenides was ensured using the EDS and FTIR technique. The EDX data show a linear increase of the Zn/Si and Cd/Si intensity ratios with an increasing n from 0.29 to 1.14, showing the homogeneity in the meso-SiO₂-MO-n, meso-SiO₂@MS-n and meso-SiO₂@MSe-n thin films. The EDS Si/Zn, Se/Zn, S/Cd, and Se/Cd intensity ratio increase and reaches to bulk ZnS, ZnSe, CdS, and CdSe values during the H₂S or H₂Se reactions, respectively, showing the complete conversion of the metal oxides to metal sulfide or metal selenide.

![Figure 1. High-resolution SEM images of the meso-SiO₂@CdS-0.86.](image-url)
films display intense Raman peaks due to longitudinal optical (LO) modes at 298, 250, and 205 cm$^{-1}$, respectively, with shoulders on their low energy side due to surface modes,[33] see Figure 2c. Notice that the Raman peaks of the CdS, ZnSe, and CdSe crystallites are quite broad compared to the bulk silicon peak at 520 cm$^{-1}$ and redshifted compared to bulk counterparts due to the phonon confinement effect.[34] For instance, there is an about 6.2 cm$^{-1}$ redshift in the meso-SiO$_2$-CdSe from its bulk CdSe. The shifts and the surface modes, observed as a shoulder on the low energy side of the LO modes, indicate the formation of nanostructured CdSe domains.[34]

To further characterize the optical properties of the films, the UV/Vis absorption spectra were also recorded using thin films, prepared over quartz or glass slides of all 4 sets of samples upon H$_2$S or H$_2$Se reactions, Figure 3. The band-gap energies of the samples were evaluated by extrapolating the absorption edge to zero on the energy axis of the square of the absorbance time energy ($A^2\times h\nu$) versus energy plots, see insets in Figure 3a, b, c, and d. The band gaps of the films were determined to be between 2.66 and 2.78 eV in the meso-SiO$_2$@CdS-$n$, 2.02 and 2.45 eV in the meso-SiO$_2$@CdSe-$n$, 3.90 and 4.07 eV in the meso-SiO$_2$@ZnS-$n$, and 2.90 and 3.43 eV in the meso-SiO$_2$@ZnSe-$n$, respectively. The band gaps in all samples are blueshifted from their bulk counterparts due to quantum size effect (bulk values are 2.42, 1.74, 3.68, and 2.70 eV, respectively).[35]

Note also that there is a gradual redshift with an increasing $n$ in the meso-SiO$_2$@MS-$n$ (or meso-SiO$_2$@MSe-$n$), indicating a gradual increase in the thickness of the metal sulfide or metal selenide domains. The thickness of the metal sulfide and metal selenide domains were calculated using the bandgap values and effective mass model (EMM) developed by Brus.[36] By using the density difference between the cadmium oxide and cadmium sulfide (or cadmium selenide) and assuming the growth of CdO nanoislands and their conversion to CdS or CdSe are lateral, one can estimate that the thickness of the CdS layers will change from 2.5 to 3.0 nm and the CdSe layer will change from 2.8 to 3.2 nm with an increasing $n$ from 0.29 to 1.14 in the meso-SiO$_2$@CdS-$n$ and meso-SiO$_2$@CdSe-$n$, respectively. The analysis of the UV/Vis data (and also using the metal oxide data[32]) also show that the 1.3–1.7 nm thick metal oxide nanoislands can be converted into 2.5–3.2 nm thick metal sulfide or metal selenide nanoflakes upon complete reaction with H$_2$S or H$_2$Se, respectively. The predicted (from density change) and determined (using UV/Vis absorption data) thickness are consistent with each other and proves our lateral growth assumption.

The films were further analyzed using N$_2$ sorption data, collected from two samples, meso-SiO$_2$@CdS-0.86 and meso-SiO$_2$@ZnS-0.86 using about 20-30 glass slides of each of the samples. Figure 4a and 4b show the N$_2$ sorption isotherms of meso-SiO$_2$-CdO-0.86, meso-SiO$_2$-(CdO-CdS)-0.86 (partially reacted), meso-SiO$_2$@CdS-0.86 (fully reacted) and meso-SiO$_2$@ZnO-0.86, meso-SiO$_2$-(ZnO-ZnS)-0.86 (partially reacted), and meso-SiO$_2$@ZnS-0.86 (fully reacted) samples. Clearly the N$_2$ sorption data show type IV isotherms with a hysteresis loops, characteristic for the mesoporous materials. The BET surface area and the Barrett–Joyner–Halenda (BJH) pore volume of the meso-SiO$_2$-CdO-0.86 increase, upon complete reaction with the H$_2$S gas, from 55 to 90 m$^2$g$^{-1}$ and from 0.16 to 0.30 cm$^3$g$^{-1}$, respectively.

The t-plots of the adsorption isotherms of the samples before the H$_2$S reaction show slight negative deviation in the 4–6 Å range, indicating the presence of some micropor-
Figure 3. UV/Vis absorption spectra with insets of the plots of the direct band-gap relation \((A^*h\nu)^2\) versus \(h\nu\) of the \textit{meso-SiO}_2@MS-\(n\) (or MSe-\(n\)) where \(n\) is shown on the plot, MS is a) CdS and b) ZnS, and MSe is c) CdSe and d) ZnSe.

Figure 4. The N\(_2\) (77.4 K) sorption isotherms with a pore-size distribution plots (the insets) before (I), partially (II), and full (III) H\(_2\)S reaction of a) \textit{meso-SiO}_2@CdS-0.86 and b) \textit{meso-SiO}_2@ZnS-0.86 and (c and d) the t-plots of the same data in (a) and (b), respectively.
occy, which disappears upon partial reaction with H$_2$S and increases upon completion of the H$_2$S reaction, see Figure 4. The H$_2$S reaction breaks the Si-O-Cd bond and peals out the CdS nanoflakes, which create extra surface area and likely more micropores between the silica walls and nanoflakes. The BET surface area of the meso-SiO$_2$-ZnO-0.86 decreases from 175 to 75 m$^2$g$^{-1}$ and the pore volume changes from 0.40 to 0.26 cm$^3$g$^{-1}$ with the complete H$_2$S reaction. The t-plots of the meso-SiO$_2$-ZnO-0.86, meso-SiO$_2$-(ZnO-ZnS)-0.86 (partially reacted), meso-SiO$_2$@ZnS-0.86 samples do not display any negative deviation, indicating absence of microporosity in the Zn$^{II}$ samples. Figure 4c and d. Note also that the percent metal oxide coating of the silica pore walls is over 90 and 35% in the meso-SiO$_2$-CdO-0.86 and meso-SiO$_2$-ZnO-0.86 samples, respectively.$^{[32]}$ The observed difference on the isotherms between the zinc and cadmium systems must lie in the degree of coating. Further studies are required to fully elucidate the surface related changes by converting metal oxides to metal sulfides and metal selenides.

The structural details of the films were investigated using the TEM and HRTEM images of a series of samples, Figure 5. The TEM images in Figure 5a and b are obtained from the meso-SiO$_2$@CdS-0.86 film upon complete H$_2$S reaction. The image shows homogeneously distributed crystalline domains trough out the films. There are 15 nm and 3.0 nm crystalline domains all over the sample, see Figure 5a–c, due to the CdS nanoflakes along the pore axis and thickness axis, respectively. Since we observe a blueshift on the absorption edge of the particles that are as large as 10–25 nm, there must be a quantum confinement on at least one of the crystallite axis. The observed blueshift on the UV/Vis absorption-edge and the plate like crystalline CdS domains in the TEM images are consistent with the formation of the nanoflakes. The images, in Figure 5c and d are the magnified domains in the squares in the images of Figure 5a and b, display lattice fringes, evenly spaced by 0.335 nm, originating from the (111) planes$^{[30]}$ of the zinc blende CdS nanoflakes. Figure 5e shows the Fast-Fourier Transform (FFT) of the image in Figure 5b showing rings due to (111), (220), and (311) planes of zinc blende CdS nanoflakes. Figure 5f is showing a HRTEM image of the meso-SiO$_2$@ZnSe-0.86 sample with a selected area electron diffraction (SAED) patterns in the inset. Each ring in the SAED pattern originates from randomly distributed nanoflakes of the ZnSe domains in the meso-SiO$_2$@ZnSe-0.86 sample. These rings, from inner to outer, correspond to the (111), (220), and (311) planes of the zinc blende ZnSe.$^{[35]}$ The distances calculated from the SAED and distances between the lattices fringes in the images (Figure 5g and h) are consistent with the unit cell parameters of zinc blende ZnSe.$^{[35]}$ From a large group of TEM images, we found that all metal oxides are converted into metal sulfides or metal selenides, which resemble the original morphology and structure of meso-SiO$_2$-MO-n thin films.$^{[32]}$

The films, upon complete H$_2$S or H$_2$Se reactions, were etched in a 4.0% aqueous HF or 2.0 m NaOH solution to further characterize the metal sulfide/metal selenide nanoflakes and to demonstrate the formation of pure mesoporous metal sulfide and metal selenide thin films. However, etching in the NaOH solution leaves silica contamination on the surface of the film, therefore the etching step has been carried out using dilute HF solution. The etching process of the meso-SiO$_2$@ZnX-n (X is S$^{2-}$ or Se$^{2-}$) films yields S and Se species (see Figure S1 and S2A), therefore they will not be discussed any further. Figure 6 shows an SEM and TEM images of the meso-CdS film that was scraped from the meso-SiO$_2$@CdS-0.86 over a glass substrate and then dropped into a 4% HF aqueous solution. Notice that the etching did not alter the sponge-like surface morphology of the film, compare Figure 6 and 1. The image in Figure 6a shows the uniformity and porosity in the film. The thickness of the film after HF treatment remained the same showing the CdO layers in the initial meso-SiO$_2$-CdO-0.86 and the CdS nanoflakes, in the meso-SiO$_2$@CdS-0.86 film are homogenously distributed. The image in Figure 6b is an expanded region from the square in Figure 6a, which shows the nanodomains with mesoporosity and the thickness of the film. TEM image shows two large nanoflakes of CdS, as the lattice fringes in each nanoflake aligned in different directions, see Figure S2B. The nanoflakes are 10-25 nm wide and
around 3.0 nm thick, see Figure S2B. The lattice fringes along the lines in Figure S2B are spaced by 0.335 nm, corresponding to the (111) planes of the zinc blende CdS lattice. Note also that the SAED patterns are also identical before and after the HF treatments, indicating that the CdS particles are as dispersed and random as before the HF treatment. Each ring from inside to out corresponds to the (111), (220), and (311) planes of the zinc blende CdS nanoflakes. The EDS measurement has been carried out on the etched samples, scraped from the film and placed over a carbon tape to ensure no silicon interference from the substrate (Si wafer or glass), Figure 6b. The Cd and S and Cd and Se peaks perfectly overlap with each other in both samples (before and after HF etching) and with their bulk counterparts, however the Si peak totally vanished upon HF etching, see Figure 6c. The EDS results obviously indicate that the silica walls could be removed from the media, where the CdS or CdSe nanoparticles remain intact and keep the film morphology.

The etched samples were further investigated using N$_2$-adsorption measurements. The N$_2$-adsorption data displays a type IV isotherm, which is characteristic of mesoporous materials. The pore shape and size distribution did not alter much upon HF etching, see Figure S2C. However, the surface area and pore volume of the etched sample dropped by 45% to 50 m$^2$/g and 47% to 0.16 cm$^3$/g, respectively, due to loss of accessible silica surfaces in the samples. Figure S2D shows the t-plots of the isotherms showing some microporocity. Remember that the H$_2$S reaction has created the accessible silica sites in the meso-SiO$_2$@CdS-0.86 and removing silica left some micropores behind in the meso-CdS film.

The UV/Vis absorption spectra of both samples, before and after etching in a 2.0 M NaOH solution clearly show that there is no damage on the CdS domains, no decomposition, no aggregation, no color change, or no further growth, see Figure S3. To improve the optical properties of meso-CdS, the grinded samples were reacted with polyethyleneimine (PEI) that is proven to be a good capping agent.[37] Figure 7 shows photographs of PEI modified meso-CdSe (meso-CdS-PEI), PEI, and meso-CdS before modification under a 365 nm UV light. The PEI modified meso-CdS becomes brightly blue luminescent under UV illumination, but the others PEI and unmodified meso-CdS do not emit, see Figure 7a, b and c. Figure 7d displays a UV/Vis absorption and photoluminescence (PL) of meso-CdS-PEI in water. The tail in the absorption spectra is likely due to some scattering. The emission spectrum shows a broad PL, peaking at 455 nm due to band gap emission, indicating all the surface traps are modified by the PEI.
Controlling the \( \text{H}_2\text{S} \) and \( \text{H}_2\text{Se} \) reactions and metal sulfide/seLENide thickness: Notice that both the \( \text{H}_2\text{S} \) and \( \text{H}_2\text{Se} \) reactions with the \textit{meso-SiO}_2-\text{MO}-\textit{n} are quite slow. We have employed the UV/Vis, FTIR and Raman spectroscopy and TEM imaging techniques to monitor these reactions to gather more information about the reaction mechanism and reaction kinetics between the films and the \( \text{H}_2\text{S} \) (or \( \text{H}_2\text{Se} \)) gas. For this purpose, we have chosen the \( \text{H}_2\text{S} \) reactions with the \textit{meso-SiO}_2-ZnO-0.86 and \textit{meso-SiO}_2-CdO-0.86 and \( \text{H}_2\text{Se} \) reaction with the \textit{meso-SiO}_2-CdO-0.86 thin films.

Figure 8a shows a series of FTIR spectra of a \textit{meso-SiO}_2-CdO-0.86 thin film that is exposed to \( \text{H}_2\text{S} \) gas for different periods of time. A similar spectral change was observed in the \( \text{H}_2\text{Se} \) and \textit{meso-SiO}_2-CdO-0.86 reaction (not shown).

The peak positions at 992 and 496 cm\(^{-1}\) are characteristic for the \textit{meso-SiO}_2-CdO-0.86 samples and gradually shift to 1067 and 456 cm\(^{-1}\), respectively, over time, see Figure 8a. The gradual shift in both peaks indicates that the \( \text{H}_2\text{S} \) reaction starts from the CdO top surface and proceeds, by the diffusion of the sulfur species, until the silica cadmium oxide interface breaks. The reaction at the interface seems to be the slowest and determining the rate of the process. Based on this proposal and the observed gradual shift on the \( \nu\text{Si}-\text{O}-\text{Cd} \) frequency, it is reasonable to suggest that the \( \nu\text{Si}-\text{O}-\text{Cd} \) interface mode(s) is very sensitive to the composition and the thickness of the CdO–CdS layers. Figure 8b displays a set of resonance Raman spectra of the \textit{meso-SiO}_2-CdO-0.86 upon exposure to the \( \text{H}_2\text{Se} \) atmosphere. The peaks due to Raman active LO modes gradually increase in intensity and shift to higher energy and become relatively sharper over time. Both blueshift (from 202.5 to 205.8 cm\(^{-1}\)) and decrease on the full-width-half-maximum (from 19.2 to 17.2 cm\(^{-1}\)) of the 1 LO mode at around 205 cm\(^{-1}\) also indicates the growth of the CdSe nanosheets over time. However, the \( \text{H}_2\text{S} \) and \textit{meso-SiO}_2-ZnO-0.86 reaction proceeds quite differently, see Figure 8c. It seems that the silica zinc oxide interface is as reactive as the ZnO domains (see below), but overall the reaction is slow.

Further information has been gathered from the spectral changes in the UV/Vis absorption and EDS spectra. The UV/Vis absorption spectra and EDS data were collected from the same samples, used for the FTIR measurement. The two representative sets of UV/Vis absorption spectra are shown in Figure 9a and b, one set from CdSe and one set from the CdS systems. With an increasing exposure time, the absorption-edge of all the \textit{meso-SiO}_2@CdS and \textit{meso-SiO}_2@CdSe gradually redshifts to the absorption-edge, recorded for the same sample upon completion of the \( \text{H}_2\text{S} \) or \( \text{H}_2\text{Se} \) reactions, see Figure 9a, and b. Therefore, these observations are consistent with the Raman observations indicative of the growth of the chalcogenites. The evaluated band gaps and thickness calculated using Brus’s expression\(^{[36]}\) were also plotted against the \( \text{H}_2\text{S} \) and \( \text{H}_2\text{Se} \) exposure time (Figure 9c and d). The spectral changes and evaluated thickness of the CdS and CdSe nanoflakes clearly show that the process is diffusion and interface limited, where the interface determines the completion of the reaction. The plot of the CdS thickness in the \textit{meso-SiO}_2-(CdO-CdS)-0.86 versus time fits best with three exponential functions and a constant. The constant is the thickness upon completion of the reaction and determined to be 2.8 nm. This thickness is consistent with the thickness calculated using the UV/Vis spectrum of the same sample after complete reaction. Each exponential function corresponds to a different rate and a different reaction, namely the reactions between the \( \text{H}_2\text{S} \) and CdO nanosheet surface (fastest), and bulk of the nanosheets (moderate), and the silica–nanosheet interface (slow, based on the spectral changes in the FTIR spectra with time), see the inset in Figure 9d. The EDS spectra of the samples at each stage of the \( \text{H}_2\text{S} \) and \( \text{H}_2\text{Se} \) reactions were also recorded and analyzed to further understand how the ZnS, CdS, and CdSe formation proceeds. The EDS spectra display a gradual increase of the S or Se peaks while the Si and Cd or Si and Zn signals remain constant during the \( \text{H}_2\text{S} \) or \( \text{H}_2\text{Se} \) reactions, see Figure 9e, f, S4A, and S4B. A similar exponential increase in the S/Zn EDS intensity ratio (as of gradual increase on the UV/Vis absorption edge) has been observed upon exposing the \textit{meso-SiO}_2-ZnO-0.86 thin films to the \( \text{H}_2\text{S} \) atmosphere (Figure S4C and S4D). However, the best fit of the EDS S/Zn intensity ratio has double exponential components with a constant of 0.39; notice that
this constant is the S/Zn intensity ratio in the bulk ZnS, indicating the completion of the reaction, Figure S4C.

Huang et al. [38] has observed a similar particle size versus time behavior of crystal growth during hydrothermal coarsening of mercatoethanol capped ZnS. The nanocrystal growth can be described by $D/D_0 = k t^{1/n}$, where $D$ and $D_0$ are particles size of the growing particle at time $t$ and $t_0$ (at beginning of the process), $k$ is a material constant and $1/n$ is related to the growth mechanism. If $n$ is equal to 3, it indicates that the growth is controlled by the volume diffusion of ions in the matrix. It is also the likely mechanism for our reaction. The linear fit of the plot $\ln(D/D_0)$ versus $\ln(t)$ provides $n$ of 3.0 for both H$_2$S and H$_2$Se reactions, if the $D_0$ is 1.44 nm for CdSe and 1.50 nm for the CdS, Figure 10. It is likely that, at these thicknesses, the CdO layers are fully coated and inaccessible for the further H$_2$S or H$_2$Se gas reaction and the reactions slow. Therefore, it is quite reasonable to suggest that the reactions are very fast up to the above thicknesses and cannot be observed by the current methods. To evaluate the $D_0$, we carried out the meso-SiO$_2$-CdO-0.86 and H$_2$Se reaction using smaller amount of H$_2$Se and collected the UV/Vis absorption spectra with a smaller intervals. Figure S5 shows the spectra and related data. The UV/Vis data shows that the initial reaction is fast; first a few CdSe layers form almost immediately, up to a thickness of about 1.4–1.5 nm. This is consistent with the estimate above.

Therefore, the silica cadmium oxide interface is the least reactive and determines the completion of the reaction. Based on the EDS, FTIR, and UV/Vis absorption spectral changes, it can be speculated that at each intermediate stage of the reaction, we have mesoporous silica cadmium oxide cadmium sulfide (or cadmium selenide) in the sponge-like mesoporous thin films (denoted as meso-SiO$_2$-(CdO-CdSe)-n and meso-SiO$_2$-(ZnO-ZnSe)-n) with a decreasing metal oxide thickness in time.

To further confirm the above proposal, we have also collected TEM images from three different sets of samples, namely

Figure 9. UV/Vis spectral changes during a) H$_2$Se and b) H$_2$S reactions with meso-SiO$_2$-CdO-0.86 thin films. The band-gap values and thickness of the nanoslands versus time plots of the c) meso-SiO$_2$@CdSe-0.86 and d) meso-SiO$_2$@CdS-0.86 (inset is the convolution of the thickness versus time plot). The EDS spectra of meso-SiO$_2$-CdO-0.86 with time under an atmosphere of e) H$_2$Se and f) H$_2$S (top EDS spectra are the bulk CdSe and CdS).

Figure 10. ln(D/D$_0$) versus ln(t) plots of the time dependent thickness data of meso-SiO$_2$-(CdO-CdSe)-0.86 and meso-SiO$_2$-(CdO-CdS)-0.86.
meso-SiO$_2$-(CdO-CdS)-0.86, meso-SiO$_2$-(CdO-CdSe)-0.86, and meso-SiO$_2$-(ZnO-ZnSe)-0.86 before and after completion of the H$_2$S and H$_2$Se reactions, see Figure 11. A TEM image of the meso-SiO$_2$-ZnO-0.86 is also shown in Figure 10a for comparison purpose. Figure 11b, e, and f show the TEM images of the partially reacted samples of meso-SiO$_2$-(ZnO-ZnSe)-0.86, meso-SiO$_2$-(CdO-CdS)-0.86, and meso-SiO$_2$-(CdO-CdSe)-0.86, respectively. The sponge-like, a few nanometer thick, and relatively darker regions in the images display lattice fringes, originating from the crystalline metal sulfide or metal selenides nanoislands. The crystalline domains follow the pattern of the silica walls as in the metal oxides; compare images in Figure 11a with b, e, and f. As proposed using spectroscopic techniques, the reactions proceed from the top surface of the oxide nanoislands until they break the Si-O-M interface, which is less reactive and requires a longer H$_2$S or H$_2$Se exposure time. Breaking the M-O-Si bond at the interface changes the overall morphology of the films at the meso-scale, but does not change at the micron-scale; compare the TEM images in Figure 5 and 11. A representative HRTEM image of the meso-SiO$_2$-(CdO-CdSe)-0.86 and its analysis (along the line in Figure 11c) are shown in Figure 11c and d, respectively. The same lattice fringes were observed in the partially and completely reacted samples in their HRTEM images. The spacing between the lines are 0.290 nm, corresponding to the (200) planes of the crystalline zinc blende CdSe. In some parts of the samples, the (111) lattice fringes are also observed from both (partially and completely reacted) sets of samples. All these observations are consistent with our top to interface diffuse controlled reaction mechanism.

Scheme 1 is a schematic representation of a reaction between the H$_2$Se gas and meso-SiO$_2$-CdO film and summarizes the overall process. The black regions, representing the nanocrystalline islands of CdO domains over the silica pore walls that react with H$_2$Se gas to produce intermediate meso-SiO$_2$-(CdO-CdSe) films. The black regions are unreacted CdO domains between the silica wall and CdSe interface and the gray domains are nanocrystalline CdSe, see middle sketch. The last sketch in the Scheme is the final product upon the completion of the H$_2$Se reaction, where the Si-O-Cd interface reacts with selenium and breaks; as a result the CdSe nanoislands peal out from the silica surface as nanoflakes.

**Conclusion**

The meso-SiO$_2$-MO-n (where M is Zn$^{II}$ or Cd$^{II}$) thin films can be reacted with H$_2$S or H$_2$Se at RT to obtain mesoporous metal sulfide or metal selenide thin films, respectively, where the CdSe to silica ratio can be as high as 79\%w/w. The H$_2$S or H$_2$Se reactions take place from the top surface of the oxides and finish upon reaction of the metal ion at the silica metal oxide interface, giving nanoflakes of metal sulfides or metal selenides, respectively. The silica metal oxide interface breaks upon completion of the reactions. However, the reactions can be stopped to obtain mesoporous silica metal oxide metal sulfide or silica metal oxide metal selenide thin films. The initial reactions are fast and produce a few atomic layers of chalcogenites that likely block and slow the volume diffusion ions and as a result the overall process. The pure mesoporous CdS and CdSe can be obtained by etching the silica domains by a dilute HF aque-
ous solution. The meso-CdS display bright blue PL upon sur-
face modification with PEI. The method developed here can
also be adapted to other metal oxides and mixed metal
oxides, which can be used to obtain their mesoporous metal
sulfide, metal selenide, and metal telluride thin films for vari-
ous applications.

Experimental Section

Preparation of meso-SiO₂-MO-n thin films: The thin films of mesoporous silica metal oxides were prepared as described in reference 32 and repre-
sented as meso-SiO₂-MO-n (where M is either Zn²⁺ or Cd²⁺ and n is metal oxide to silica molar ratio and is 0.29, 0.57, 0.86, and 1.14).

Preparation of meso-SiO₂-(MO-MS)ₙ and meso-SiO₂@MS-n thin films: Insert the calcined meso-SiO₂-ZnOₙ or meso-SiO₂-CdOₙ thin films into a vacuum chamber and evacuate the chamber for 2 min. Expose the samples to 300 Torr H₂S gas either desired period or until complete reaction (see below) to obtain meso-SiO₂-ZnOₙ or meso-SiO₂-CdOₙ thin films. Then, pump out the unreacted excess H₂S gas from the reaction media for 5 min before removing the sample from the reaction chamber. The meso-
SiO₂-ZnOₙ-ZnSe and meso-SiO₂-CdOₙ-CdS thin films were repeatedly ex-
posed in several steps to the same atmosphere and monitored using UV/Vis and EDS spectroscopy.

Preparation of meso-SiO₂-(MO-MSe)ₙ and meso-SiO₂@MSe-n thin films: Insert the calcined meso-SiO₂-ZnOₙ or meso-SiO₂-CdOₙ thin films into a vacuum chamber and evacuate the chamber for 2 min. Expose the meso-SiO₂-ZnOₙ and meso-SiO₂-CdOₙ samples to 300 Torr of 5% H₂Se gas (diluted with pure N₂ gas) for 1 h for a complete reaction to obtain meso-SiO₂-ZnOₙ-ZnSe and meso-SiO₂-CdOₙ-CdSe thin films, respectively or repeatedly exposed to the same atmosphere, several times within 1 h to obtain partially reacted meso-SiO₂-ZnOₙ-ZnSe and meso-
SiO₂-CdOₙ-CdSe samples. Then, first evacuate the unreacted H₂Se gas into a Cd²⁺ loaded mesoporous silica for 2 min to convert the excess H₂Se into copper selenide species. Then, evacuate the reaction chamber by pumping using a rotary pump for 5 min.

Preparation of the meso-CdS and meso-CdSe thin films: Dip the meso-
SiO₂@MS (or MSe, M is Zn²⁺ or Cd²⁺) film into 10 ml 4% HF solution for 1 second. Then, remove and wash the film with deionized water and dry it at RT. For the powder samples, first obtain the powder samples by scraping the films from the glass slides and then immerse the powder into a 10 ml 4% HF solution for a few minutes. Following that centrifuge and deposite the solution into an HF disposal container. Add deion-
ized water and repeat the centrifugation and decantation step several times to wash out all the fluoride species. Then dry the powder in a 100°C oven overnight.

Surface modification of meso-CdS with PEI: 1 mg of HF acid etched
meso-CdS and excess amount of PEI (polyethyleneimine) are dissolved in absolute ethanol. The PEI and meso-CdS solution was kept in a soni-

cator for 5 min. Evaporation of the solvent give photoluminescent (PL) PEI modified meso-CdS (denoted as meso-CdS-PEI). The PL was mea-
sured upon dispersion of meso-CdS-PEI in deionized water.

Characterization: The Fourier transform infrared (FTIR) spectra were re-
corded using a Bruker Tensor 27 model FTIR spectrometer. A Digt-
tect TM DLATGS detector was used with a resolution of 4.0 cm⁻¹ in the
400–4000 cm⁻¹ range. The spectra were recorded using the dry KBr pellets. The UV/Vis absorption spectra were recorded using thin films coated over quartz or glass substrates and uses a Thermo Scientific Evolution 300/600 UV/Vis spectrophotometer. The micro-Raman spectra were recorded on a LabRam confocal Raman microscope with a 300 mm focal length. The spectrometer is equipped with a Ventus LP 532 50 mW, diode-pumped solid-state laser operated at 20 mW, with a polarization ratio of 100:1 and a wavelength of a 532.1 nm and a 1024 × 256 element CCD camera. The signal collected was transmitted via a fiber optic cable into a spectrometer with a 1800 g/mm gratings. The Raman spectra were collected by manually placing the probe tip near the desired point of the sample on a silicon wafer. The x-ray diffraction (XRD) patterns were re-
corded on a Rigaku Miniflex Diffractometer using a high power CuKα source operating at 30 kV/15 mA. The polarized optical microscopy (POM) images were obtained in transmission mode on a ZEISS Axiom Scope A1 Polarizing Optical Microscope. The scanning electron micro-
scopy (SEM) images and energy dispersive x-ray spectroscopy (EDS) data were collected using ZEISS EVO-40 operating at 15 kV and the same mi-
croscope using Bruker AXS XFlash detector 4010, respectively. The high resolution SEM images were recorded using FEI Nova 600i NanoLab Dual Beam TM-SEM. The high resolution transmittance electron micro-
scope (HRTEM) images were recorded on a FEI Tecnai G2 F30 at an operating voltage of 200 kV. The film samples were scribed and ground well in a mortar using 5 ml of ethanol and dispersed using a sonicator for 5 min. One drop of the dispersed ethanol solution was put on a TEM grid and dried over a hot-plate. The N₂ (77.4 K) sorption measurements were performed with a TriStar 3000 automated gas adsorption analyzer (Micrometrics) in a relative pressure range, P/P₀ from 0.01 to 0.99. To provide high accuracy and precision in the determination of P/P₀ the sat-
turation pressure Pₛ was measured over 120 min intervals. The powder sample, which was obtained by scraping about 20 glass slides of each film samples, was dehydrated under (ca. 10⁻³ Torr) vacuum for 3 h at 250°C to remove adsorbed water and other volatile species from the pores before the N₂ sorption measurements were recorded. The PL of the meso-CdS-PEI that is dispersed in deionized water in a quartz cell was measured using Varian Cary Eclipse fluorescence spectrophotometer. An excitation wavelength of 365 nm was used and the PL is from 380 to 700 nm. The excitation and emission slit widths were both set to 10 nm.

Acknowledgements

The financial support of TUBITAK under the project 110T183 and the Turkish Academy of Science are deeply appreciated. We also thank to Mustafa Güler for the TEM images.

Chemical Approach to Nanomaterials, 2nd ed., Royal Society of
eence 2006, 314, 274.
2003, 42, 3604.

Received: August 25, 2011
Published online: February 16, 2012